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**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Kim et al. Serial No.: 10/601,475 Filed: June 23, 2003 Group Art Unit: 2811
Examiner: To Be Assigned
Confirmation No.: 7249

For: SEMICON

SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES THAT

FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE

CONTAMINATION AND METHODS OF FORMING SAME

Date: November 29, 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a Second Supplemental Form PTO-1449 listing documents cited in an Office Action for corresponding German Application Number 103 37 757.3-33. Each document listed on the attached PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of any listed foreign patent document and/or non-patent literature including the Office Action, is enclosed.

It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. §1.56 and Section 609 of the MPEP. No fee is believed due; however, the Commissioner is hereby authorized to charge any deficiency or credit any refund to Deposit Account No. 50-0220.

Respectfully submitted

istration No. 36925

USPTO Customer No. 20792

Myers Bigel Sibley & Sajovec Post Office Box 37428

Raleigh, North Carolina 27627 Telephone: 919/854-1400 Facsimile: 919/854-1401

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 29, 2005.

Candi L. Riggs

LIST	Pate OF DO	U.S. Department of the contract of the contrac	Office	CANT	Attorney Docket Number 5649-921			Serial No. 10/601,475
DEC 0 1 2005					Applicants: Kim et al.  Filing Date: June 23, 2003			
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	1	101 31 246 A1	3/7/2002	DE		H01L21	304	
	2	06314676 A	11/8/94	JP		H01L21	304	
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	3	Office Action, G	erman Applic	cation No. 103	37 757.3-33, Oc	tober 7, 2005	)	
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